## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

NAKAMURA et al

Atty. Ref.: 160-399; Confirmation No.

Appl. No. To be Assigned

Group:

Filed: November 24, 2003

Examiner:

For: NITRIDE SEMICONDUCTOR WITH ACTIVE LAYER OF QUANTUM WELL STRUCTURE WITH INDIUM-CONTAINING NITRIDE SEMICONDUCTOR

\* \* \* \* \* \* \* \* \* \* \*

November 24, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

7

## **PRELIMINARY AMENDMENT**

In order to place the above-identified application in better condition for examination, please amend the application as follows:

NAKAMURA et al Appl. No. To be Assigned November 24, 2003

## IN THE TITLE

7

Amend the title so that it reads as follows:

NITRIDE SEMICONDUCTOR DEVICE WITH ACTIVE LAYER OF

QUANTUM WELL STRUCTURE WITH INDIUM-CONTAINING NITRIDE

SEMICONDUCTOR